

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Isuyoshi SAITO et al.

Serial No.: 09/901,577

Filing Date: July 11, 2001

Group Art Unit: 2661

Examiner: Unknown

RECEIVED

JUL 1 2 2002

Technology Center 2600

For: SEMICONDUCTOR MANUFACTURING APPARATUS, REMOTE CONTROL
SYSTEM THEREFOR, AND REMOTE OPERATION DEVICE

Assistant Commissioner of Patents
Washington, D.C. 20231

RECEIVED

JUL 1 6 2002

Technology Center 2100

INFORMATION DISCLOSURE STATEMENT

Sir:

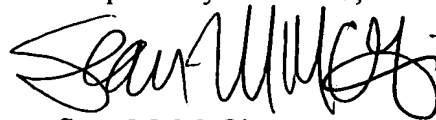
Under the provisions of 37 CFR §1.97 through §1.99 and pursuant to applicant's duty of disclosure under 37 CFR §1.56, applicant respectfully brings the following documents listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. Copies of the listed documents are provided herewith for the convenience of the Examiner. English-language Abstracts are attached to the references.

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which the applicant is aware.

It is respectfully requested that the listed references be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,



Sean M. McGinn

Registration No. 34,386

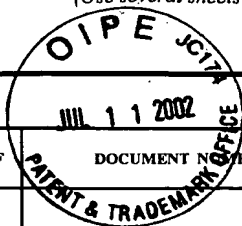
Date:

7/11/02

McGinn & Gibb, PLLC
Intellectual Property Law
8321 Old Courthouse Road, Suite 200
Vienna, VA 22182-3817
(703) 761-4100
Customer No. 21254

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

KOKUSAI 0

Application Number

09/901,577

Applicant(s)

Tsuyoshi SAITO et al.

Filing Date

July 11, 2001

Group Art Unit

2661

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
				RECEIVED			
				JUL 16 2002			
				Technology Center 2100			
						RECEIVED	
						JUL 12 2002	
						Technology Center 2600	

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		61-129945	06/17/86	JAPAN			ABS	
		10-097966	04/14/98	JAPAN			ABS	
		11-15520	01/22/99	JAPAN			ABS	
		10-268930	10/09/98	JAPAN			ABS	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.